



**ELECTRONIC COPY**

LG752573086  
Report verification at igi.org



December 4, 2025

IGI Report Number **LG752573086**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **7.28 X 5.01 X 3.43 MM**

**GRADING RESULTS**

Carat Weight **1.08 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

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**GRADING RESULTS**

Carat Weight **1.08 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

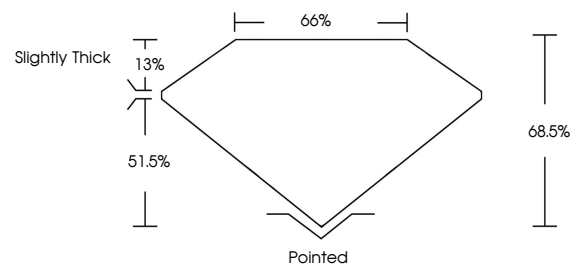
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG752573086**

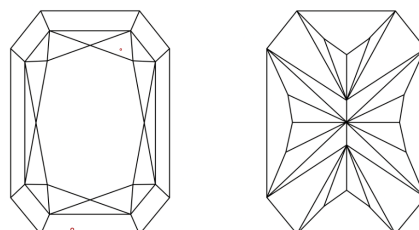
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

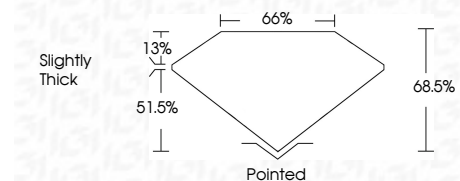
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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CUT CORNERED RECT. MODIFIED BRILLIANT  
1.08 CARAT E  
7.28 X 5.01 X 3.43 MM  
Color Grade E  
Clarity Grade VS 1  
Table 68.5%  
Girdle 65%  
Slightly Thick  
Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG752573086  
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Type IIa